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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10061514	FILING DATE 02/01/2002	CLASS 215	SUBCLASS 5.4	GAU 1738	EXAMINER Alanto
APPLICANTS: Hest, Jeffrey;					
CONTINUING DATA VERIFIED:					
RELATED APPLICATIONS VERIFIED:					
DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>		ATTORNEY LOCKET NO.	
<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no		10010150-2			
SUBJECT: Substrate and method of forming substrate for fluid ejection device					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner Application Examiner	
		PREPARED FOR ISSUE	
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